IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Art Unit: 3723

Kajiwara et al. Serial No. 09/874,174 Examiner: MORGAN, Eileen P. Attorney Docket No. A-70092/RMA

Filed: June 4, 2001

Date: December 13, 2004

For:

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PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.136(a), a petition for an extension of time of (1) one month is hereby requested to respond to the Office Action mailed August 12, 2004.

The Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No. 50-2319 (Order No. <u>A-70092/RMA</u>).

Respectfully submitted,

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By:

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CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service with Sufficient postage as firs class mail in an envelope addressed to COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450, on this date: DECEMBER 13, 2004 32 502319				- 3374 274

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